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Enhancing interfacial charge transfer in WO₃/BiVO₄ photoanode heterojunction through gallium and tungsten co-doping and sulfur modified Bi₂O₃ interfacial layer

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Section 1: Calculation processes

Photoelectrochemical measurements

The reference electrode potential was converted to reverse hydrogen electrode (RHE) by the relationship given in (equation (1)).

$$E_{RHE} = E_{Ag/AgCl}^{0} + E_{Ag/AgClSCE} + 0.059 \, pH \tag{1}$$

Where
$$E_{Ag/AgCl}^{0} = 0.1976 V vs. RHE, at 298 K$$

Process of theoretical photocurrent (J_{theoretical} calculation)

The light-harvesting efficiency (LHE) or absorption efficiency (ϕ_{abs}) relationship is show in (equation (2))

$$LHE = 1 - 10^{-A(\lambda)} = \phi_{abs} \tag{2}$$

Where A is absorbance with wavelength (λ)

The absorption efficiency was calculated by integrating absorption spectra from wavelength 300 to 550 nm for all samples.

Further, photon energy and photon flux calculated from AM1.5G solar irradiance with wavelength as given in Figure S1b by following relation (equation (3-5)).

$$E(\lambda) = h \times C/\lambda \tag{3}$$

Where, $E(\lambda)$: photon energy h: Plank constant C: speed of the light

Number of photons =
$$h \times C/\lambda$$
 (4)

Photons flux
$$(\phi(\lambda)) = P(\lambda)/E(\lambda)$$
 (5)

The above-calculated data, theoretical photocurrent was calculated assuming 100% incident to photon conversion efficiency (IPCE) and by the following relationship.^{1,2}

$$J_{theoretical} = \int_{\lambda_1}^{\lambda_2} e^{-x} \phi(\lambda) \times LHE \times d\lambda$$
(6)

Charge transport calculation: bulk and surface

Major losses in theoretical photocurrent are electron-hole recombination in the bulk and at the surface, which are known as charge separation (ϕ_{sep}) and charge transfer or charge injection efficiency (ϕ_{trans}), by relationship equation (7 and 8).

$$J_{H_2O} = J_{theoretical} \times \phi_{sep} \times \phi_{trans} \tag{7}$$

The transfer efficiency is almost 100% in the presence of hole scavengers, given by relationship equation (10).²

$$J_{Na_2SO_3} = J_{theoretical} \times \phi_{sep} \tag{8}$$

Using equation (7 and 8) the ϕ_{sep} and ϕ_{trans} can be calculated

IPCE calculation

The IPCE was measured by the relationship given in equation (9)

$$IPCE = \frac{Number of electrons}{Number of photons} = \frac{J_{monochromator} \times h \times C}{P_{monochromator} \times \lambda}$$
(9)

Integrated current calculation

Integrated current (J_{integrated}) was calculated using the relationship given in eq (10)

$$J_{Integrated} = \int_{\lambda_1}^{\lambda_2} e^{-} \times \phi(\lambda) \times IPCE \times LHE \times d\lambda \tag{10}$$





Figure S1. Chopped light J-V plot for 1- 6 wt % Ga-doped BiVO₄ in KPi electrolyte. (b) Fabrication steps of $WO_3/S:Bi_2O_3/(Ga,W):BiVO_4$ sample.



Figure S2. J-V plots under simulated AM 1.5G illumination in KPi for (a) WO₃/doped BiVO₄ photoanodes, (b) different layers of Bi₂O₃ with WO₃/doped BiVO₄, (c) heterojunction between S:Bi₂O₃ and doped BiVO₄.

Section 3: Photocurrent measurements of hole scavengers

The photocurrent was also measured with a hole scavenger (Na₂SO₃), where the electron-hole

recombination is considered almost negligible.1

¹ As observed from Figure S3, WO₃/S:Bi₂O₃/(Ga,W):BiVO₄ exhibited the highest photocurrent of $6.4\pm0.3 \text{ mA.cm}^{-2}$ compared to $5.86\pm0.3 \text{ and } 5.4\pm0.28 \text{ mA.cm}^{-2}$ for WO₃/Bi₂O₃/(Ga,W):BiVO₄ and

WO₃/(Ga,W):BiVO₄ photoanodes, validating the significance of implementing an interfacial layer S:Bi₂O₃.



Figure S3. J-V plots under 1 sun illumination for photoanodes with WO₃ heterojunction and Bi₂O₃ interface layer with and without sulfur modification in KPi with hole scavenger (1M Na₂SO₃).

Section 4: Mott Schottky and flat-band calculation

Mott-Schottky estimated flat band (onset) potential–Schottky at 1 kHz in the dark with AC amplitude of 20 mV at 1.23 V vs RHE in $0.1 \text{ M K}_2\text{HPO}_4$ electrolyte (pH 7.5) by the relationship given in equation (12).¹

$$\frac{1}{C^2} = \frac{2}{(\varepsilon \varepsilon_0 A^2 e N_D)} \left(V_{app} - V_{FB} - \frac{K_B T}{e} \right)$$
(12)

Where C is the capacitance in space charge region; ε is relative permeability which is taken as³ for the calculation; ε_0 is vacuum permeability (8.8 ×10⁻¹² F m⁻¹); A (cm²) is the area of the photoanode thin film; e is the charge of an electron (1.602 × 10⁻¹⁹ C); N_D is the number of charge carrier per cm⁻³, estimated from Mott-Schottky measurement plot (Table S1); V_{app} (in RHE) is the applied potential; V_{FB} is the flat band potential measured from Mott-Schottky plot; K_B is

Boltzmann constant (1.38 \times 10-23 J K⁻¹); T (K) is the temperature at which the measurement is performed (298 K).

Mott-Schottky measurements were performed in the frequency range of 0.7 - 2.8 kHz in the dark (Figure S4 a-d). Mott-Schottky measurements demonstrated the cathodic shift (Figure S4e) in the flat-band potential compared to the i-BiVO₄ that signified the reduced surface recombination.³ The cathodic shifts in the flat-band potentials were 158, 202 and 209 mV, whereas corresponding shifts in the onset potentials for photocurrent were 380, 410 and 440 mV (Figure S4f) for WO₃/(Ga,W):BiVO₄, WO₃/Bi₂O₃/(Ga,W):BiVO₄ and WO₃/S:Bi₂O₃/(Ga,W):BiVO₄ photoanodes compared to i- BiVO₄. There were further 91 mV cathodic shift noticed on Co-Pi deposition for WO₃/S:Bi₂O₃/(Ga,W):BiVO₄/Co-Pi photoanodes. The slight difference in onset potential and flatband potential could be due to the rate limitation in charge transfer to photoanode surface/electrolyte interface and recombination in space charge layer.⁴ As shown in Figure S4e (inset), the shift in the CB edge for WO₃/S:Bi₂O₃/(Ga,W):BiVO₄ photoanode was much closer to the H_2 evolution potential (0 V_{RHE}), lessening the overpotential for driving hydrogen evolution reaction (HER) but increasing that available for driving the more difficult oxygen evolution reaction (OER), which provides a more favorable balance for the overall water splitting kinetics. The flat band was assumed to be equal to the CB edge, a good approximation for highly doped photoanodes.⁵ The CB edge shift (Figure S4e: inset, Table S1) was more pronounced due to Ga and W co-doping and even more substantial with heterojunction formation and S modification. The frequency dependency of the Mott-Schottky data was verified by conducting additional Mott-

Schottky analysis at frequency values of 0.5, 1 and 2 kHz^{4,6,7} in 0.1 M K₂HPO₄ electrolyte in the dark (see Figures S4 a-d) for i-BiVO₄, WO₃/(Ga,W):BiVO₄, WO₃/(Ga,W):BiVO₄ and

 $WO_3/S:Bi_2O_3/(Ga,W):BiVO_4$ photoanodes. As seen from these figures, the x-axis intercepts were close for all frequencies. The frequency dependency was also validated on real and imaginary impedance values. As seen from Figure S4 (g and h), the real impedance was unaffected with the change in frequency values, but the imaginary impedance showed log-log dependency with the slope value of -0.88±-0.15. High frequencies were selected in order to have a smaller time scale, which can abstain from the sufficient filled and vacant surface states or buildup of a double layer capacitance.⁸



Figure S4. Mott-Schottky analysis in KPi electrolyte measured in the dark at different frequencies of (a) $BiVO_4$, (b) $WO_3/(Ga,W)$: $BiVO_4$ (c) $WO_3/Bi_2O_3/(Ga,W)$: $BiVO_4$, and (d) WO_3/S : $Bi_2O_3/(Ga,W)$: $BiVO_4$ photoanodes. (e) Mott-Schottky analysis in KPi electrolyte measured in the dark (inset: the shift in the CB edge) for photoanodes with WO_3 heterojunction and Bi_2O_3 interface layer with and without sulfur modification. (f) photocurrent onset measurement in KPi under Simulated AM 1.5G illumination. Frequency-dependent relationship of (g) real and (h) imaginary impedance.

Section 5: Absorption, charge separation and transport

Figure S5c shows charge separation (ϕ_{sep}) and hole transfer efficiencies (ϕ_{trans}), where it is seen that the Ga doped sample demonstrated better ϕ_{sep} (38%) compared to i-BiVO₄ (26%), likely due to improved conductivity and increased charge carrier concentration (Table S1). Likewise, the codoped sample (Ga,W):BiVO₄ exhibited better charge separation (66%) compared to W:BiVO₄ (62%). This is possibly due to the cumulative effect of W and Ga where Ga acts as an electron donor, forming a diffusion path that reduces recombination of photogenerated charge carriers.^{2,9} Correspondingly, ϕ_{trans} in Figure S5d follows a similar trend to that of ϕ_{sep} where (Ga,W):BiVO₄ samples exhibit the highest charge transfer rate (51%) compared to W:BiVO₄ (35%), Ga:BiVO₄ (16%) and BiVO₄ (8.4%) samples. The calculated ϕ_{sep} and ϕ_{trans} for the heterojunction based sample $WO_3/S:Bi_2O_3/(Ga,W):BiVO_4$ (Figure S5e and f) demonstrated the highest ϕ_{sep} (95%) compared to $WO_3/Bi_2O_3/(Ga,W):BiVO_4$ (89%) and WO₃/(Ga,W):BiVO₄ (87%). Correspondingly, the obtained ϕ_{trans} for WO₃/S:Bi₂O₃/(Ga,W):BiVO₄ photoanode was highest ϕ_{trans} (80%) compared to WO₃/Bi₂O₃/(Ga,W):BiVO₄ (65%) and WO₃/(Ga,W):BiVO₄ (53%). This validates that using the S:Bi₂O₃ interfacial layer can facilitate photogenerated charge separation and act as a blocking layer for holes generated in BiVO₄ absorber layer. In this case, electrons generated in the BiVO₄ can rapidly transport to the charge collector which reduces the probability of electrons becoming trapped at recombination sites. In parallel, holes can readily transfer to the reaction surface for water splitting.



Figure S5. (a) Absorption spectra (inset: absorption efficiency), (b) bandgap, (c) charge separation efficiency (ϕ_{sep}) and (d) charge transfer efficiency (ϕ_{trans}) for all doped photoanodes. (e) charge separation efficiency (ϕ_{sep}) and (f) charge transfer efficiency (ϕ_{trans}) for photoanodes with WO₃ heterojunction and Bi₂O₃ interface layer with and without sulfur modification.



Section 6: Scanning electron microscopy of BiVO₄, WO₃, Bi₂O₃ and FTO substrate

Figure S6. Surface morphology of (a) i-BiVO₄, (b) WO₃, (c) Bi_2O_3 . (d) Cross-sectional image of FTO coating on the glass substrate.

Section 7: XRD

The phase identification, purity and crystal structure of all fabricated thin films were examined using XRD (PANalytical X'Pert PRO MRD; Cu Kα radiation; 0.006 degrees per sec). The crystal structure was determined using XRD analysis for intrinsic and doped BiVO₄, Bi₂O₃ and WO₃ in Figure S7a. It was noticed that all characteristic peaks of BiVO₄ were matched with standard PDF #014-0688 and confirmed the clinobisvanite (monoclinic scheelite) structure. However, there were no doping-oriented peaks identified after 4 wt% Ga and 1.3 wt% W doping in BiVO₄, which validated that doping did not make any changes in the crystal structure/space group of BiVO₄.

 Bi_2O_3 was identified to have a tetragonal phase with standard PDF # 18-0244 whereas WO₃ had a monoclinic form with standard PDF # 43-1035. In the next step, XRD analysis was conducted for heterojunction samples in Figure S7b. The individual peaks of WO₃, Bi_2O_3 and $BiVO_4$ were identified and confirmed the successful formation of a heterojunction without any complex phases. There were no S oriented peaks identified, possibly due to the small amount of S in the film $WO_3/S:Bi_2O_3/(Ga,W):BiVO_4$.



Figure S7. XRD analysis of (a) WO_3 , Bi_2O_3 , $BiVO_4$ and (Ga, W): $BiVO_4$ and (b) photoanodes with WO_3 heterojunction and Bi_2O_3 interface layer with and without sulfur modification.

Section 8: XPS

XPS was employed to determine the oxidation state of Bi, V, W, Ga and O in the WO₃/S:Bi₂O₃/(Ga,W):BiVO₄ sample. From Figures S8a-e, the major peaks for Bi $4d_{3/2}$ (467.5 eV), Bi $4d_{5/2}$ (443.8 eV), Bi $4f_{5/2}$ (167.7 eV), Bi $4f_{7/2}$ (159.4 eV), V $2p_{1/2}$ (524.4 eV), V $2p_{3/2}$ (516.9 eV), W $4f_{5/2}$ (38.9 eV), W $4f_{1/2}$ (35.9 eV), Ga $2p_{1/2}$ (1144.7 eV), Ga $2p_{3/2}$ (1118 eV) were observed and attributed the oxidation states as +3 and +5, +6 and +3 for Bi, V, W and Ga, respectively. XPS spectra in the O 1s in Figure S8f illustrates the nominal oxidation state of O (-2) with lattice oxygen (V–O) at 530 eV, and the shoulder at 531 eV confirmed the surface-adsorbed oxygen (–OH). No







Figure S8. XPS surface spectra of (a) Bi 4d, (b) Bi 4f, (d)V 2p, (e)W 4f, (f) Ga 2p and (g) O 1s. (g) XPS depth profiling spectra for S 2s. (h) Prepared samples for the XPS surface analysis to determine the state of sulfur.

(a) Film fabrication steps S-treated (Ga,W):BiVO₄ WO₃/S:Bi₂O₃/WO₃/S:Bi₂O₃/ S-dip WO₃ WO₃/Bi₂O₃ WO3/Bi2O3 WO3/Bi2O3 deposition on (Ga,W):BiVO₄ (Ga,W):BiVO₄ WO₃/S:Bi₂O₃ Complete Short (WO₃/S:Bi₂O₃) WO₃/S:Bi₂O₃/ (Ga,W):BiVO₄ annealing annealing (5 min at 500°C) (2 h at 500°C) Control (No annealing) **(b)** (c) 10^4 νØ 10⁴ Intensity (counts) 10³ Vo Intensity (counts) 10 GaÖ Bi Gar 10^{2} 10¹ 10¹ (Ga,W):BiVO4 W):Bi S:Bi₂O WO S:Bi₂O₃ WO **10**⁰ 10⁰ 2000 1000 0 500 1500 2500 1000 2000 3000 4000 0 Sputter Time (s) Sputter Time (s) (d) Wo. **10⁴** Vr Bi Intensity (counts) GaO **10³ 10² 10¹** S:Bi₂O₃ WO₃ 10^{0} 3000 4000 5000 0 1000 2000 6000 Sputter Time (s)

Section 9: TOF-SIMS depth profiling

Figure S9. (a) Process of prepared samples for depth profiling in three distinct environments. Negative polarity time of flight secondary ion mass spectroscopy (TOF-SIMS) analysis of sample $WO_3/S:Bi_2O_3/(Ga,W):BiVO_4$ in three distinct environments (b) control (no annealing), (c) short annealing (5 min at 500°C) and (d) complete annealing (2h at 500°C) for Bi⁻, VO⁻, WO²⁻, GaO⁻,

 S^{-} , F^{-} , Sn^{-} and Si^{-} species. Note the substrate signals appear midway through the film due to the poor depth resolution of the profiles, owing to the roughness of the films at the start of profiling



Section 10: Randles circuits and reproducibility validation

Figure S10. (a) and (b) Randles circuit for calculating $R_{surface}$, R_{bulk} , $C_{surface}$ and C_{bulk} . (c) R_{tot} calculated by $\left(\frac{dI}{dV}\right)^{-1}$ and fitting was done using GaussMod function in OriginPro 2020.



Figure S11. J-V plot after stability measurement for reproducibility validation of photoanodes with WO₃ heterojunction and Bi₂O₃ interface layer with and without sulfur modification.

Tables

Photoanode	PCD (mA.cm ⁻²)	Band Gap (eV)	Current onset (V)	Flat band Potential (V)	Charge carrier density (cm ⁻³)	
WO ₃		2.71				
Bi ₂ O ₃		2.8				
i-BiVO ₄	0.25 ± 0.01	2.42	0.23	0.25	2.8916E+19	
Ga:BiVO ₄	0.4 ± 0.02	2.39	0.18	0.21	9.62267E+19	
W:BiVO ₄	1.02 ± 0.04	2.41	0.11	0.18	1.04236E+20	
(Ga,W):BiVO ₄	1.68 ± 0.1	2.38	0.07	0.15	1.04236E+20	

Table S1: Result summary: WO3, Bi2O3, intrinsic and modified BiVO4

Table S1b: Result summary: heterojunction samples, Bi₂O₃ layer without and with sulfur.

Photoanode	PCD (mA.cm ⁻²)	PCD in Hole scavang er (mA.c m ⁻²)	Current onset (V)	Flat band Potential (V)	Charge carrier density (cm ⁻³)	IPCE (%)
WO ₃ /(Ga,W):BiVO ₄	2.8±0.12	5.4±0.2 6	-0.15	0.092	1.14522E+20	43.2
WO ₃ /Bi ₂ O ₃ /(Ga,W):BiVO ₄	3.27±0.15	5.86±0. 28	-0.18	0.048	1.26141E+20	53.5
WO3/S:Bi ₂ O ₃ /(Ga,W):BiVO ₄	4±0.2	6.4±0.3	-0.21	0.041	1.80388E+20	63.25
WO3/S:Bi ₂ O ₃ /(Ga,W):BiVO ₄ /Co- Pi	5.1±0.25					73.5

Table S2: Time-resolved PL analysis calculated parameters

Photoanode	A_1	τ_1 (ns)	A_2	τ_2 (ns)	$<_{\tau}>$ (ns)	$K_{et}(ns^{-1})$
WO ₃ /(Ga,W):BiVO ₄	646.31±81.42	0.34±0.03	23.88±8.94	1.39±0.24	$0.477 {\pm} 0.05$	2.095±0.20
WO ₃ /S:Bi ₂ O ₃ /(Ga,W):BiVO ₄	679.97±90.52	0.31±0.03	37.54±17.41	1.02±0.18	0.418±0.04	2.393±0.22

Table S3: fs-TA analysis calculated parameters of dry film

	WO ₃ /(Ga,W):BiVO ₄	WO ₃ /S:Bi ₂ O ₃ /(Ga,W):BiVO ₄			
	А	τ (ps)	А	τ (ps)		
τ_1	1.06E-02	1.164	1.95E-03	1.947		
τ_2	5.50E-03	31.15	1.45E-03	60.45		
τ_3	2.96E-03	4640	1.35E-03	8233		

Table S4: ns-TA analysis calculated parameters in operando

	WO ₃ /(Ga,W):BiVO ₄			WO ₃ /S:Bi ₂ O ₃ /(Ga,W):BiVO ₄			
	А	τ (ns)	$K_{TA} (ns^{-1})$	А	τ (ns)	K _{TA} (ns ⁻¹)	
τ_1	0.43	2.5	0.4	0.35	1.1	0.909	

τ_2	0.38	43	0.023	0.37	36	0.0278
τ_3	0.21	1300	0.0008	0.21	1100	0.0009
τ_4	0.07	>100000	<0.00001	0.07	>100000	<0.00001

Table S5: Comparison of improved photocurrent density in WO₃/BiVO₄ *heterojunction with various interfacial layers.*

	Photoanode	Electrolyte	Photocurr ent	Month	Year	Ref
			(mA.cm ⁻²)			
1	FTO/WO ₃ /BiVO ₄ /Au	0.5 M Na ₂ SO ₄	0.072	January	2010	10
2	BiVO ₄ /SnO ₂ /WO ₃	0.1 M Na ₂ SO ₄	2.7	March	2012	11
3	BiVO ₄ /WO ₃ /W	0.1 M KH ₂ PO ₄	2.01	October	2015	12
4	WO ₃ /BiVO ₄ /TiO ₂ core-shell	0.1 M Na ₂ SO ₄	4.2	October	2016	13
5	BiVO ₄ /WO ₃ /SnO ₂	Phosphate buffer	3.1	December	2016	14
6	WO ₃ /W:BiVO ₄ /BiVO ₄	0.5 M Na ₂ SO ₄	2.74	January	2017	15
7	BiVO ₄ /(RGO/WO ₃)/W ₁₈ O ₄₉ /FeOOH/ NiOOH	0.5 M Na ₂ SO ₄	2.4	January	2018	16
8	FTO-BiVO ₄ -W-WO ₃	0.1 M Na ₂ SO ₄	2.7	June	2018	17
9	Al2O3/BiVO ₄ /WO ₃	2.0 M KHCO ₃	4	June	2018	18
10	FeOOH/Au-surface/BiVO ₄ /WO ₃ /Au- bottom	0.5 M Na ₂ SO ₄	1.97	December	2018	19
11	WO3/BiVO4/ZnO	0.5 M Na ₂ SO ₄	2.96	December	2018	20
12	TiO ₂ /BiVO4/SnO ₂	0.5 M phosphate buffer	2.3	January	2019	21
13	3D TiO ₂ /WO ₃ /BiVO ₄ /FeOOH/NiOOH TiO2/WO3/BiVO4/FeOOH/NiOOH	0.5 M Na ₂ SO ₄	4.27	June	2019	22
14	WO ₃ /BiVO ₄ /BiOCl	0.1 M Na ₂ SO ₄	0.00724	June	2019	23
15	FTO WO3/CuWO4 BiVO4	0.1 M phosphate buffer	0.66	April	2019	24
16	WO ₃ /BiVO ₄ (BVO)/BiFeO ₃	$0.5 \text{ mol} \cdot L^{-1} \text{ Na}_2 \text{SO}_4$	1.5	August	2019	25
17	WO ₃ -TiO ₂ -BiVO ₄	0.1M Na ₂ S+0.2M NaOH	0.03	November	2019	26
18	CNP/B-BiVO ₄ /WO ₃	0.1 M Na ₂ SO ₄	0.44	March	2020	27
19	WO ₃ /BiVO ₄ _Bi-PED	$ \begin{array}{c} & Na_2 SO_4 \ 0.5 \ mol \ L^{-1} \\ + \ Na_2 HPO_4 \ 0.1 \ mol \ L^{-1} \\ & pH \ 7.0 \end{array} $	2.1 ± 0.3	June	2020	28

20	WO ₃ /BiVO ₄ /TANiFe	Borate buffer	3.7	July	2020	29
21	WO ₃ /S:Bi ₂ O ₃ /(Ga,W):BiVO ₄	0.1 M K ₂ HPO ₄	4		2021	This work
22	WO ₃ /S:Bi ₂ O ₃ /(Ga,W):BiVO ₄ /Co-Pi	0.1 M K ₂ HPO ₄	5.14		2021	This work

Table S6: Comparison of hydrogen generation rate for BiVO₄ based heterojunction.

	Photoanode	Electrolyte	Gas collection rate $(\mu mol h^{-1} cm^{-2})$		Month	Year	Ref
			H_2	O ₂			
1	BiVO ₄ /FeOOH/NiOOH	0.5 M Na ₂ SO ₄	3.5	1.84	February	2014	30
2	WO3-NRs/BiVO4+CoPi	0.5 M Na ₂ SO ₄	47.8	23.6	May	2014	31
3	WO ₃ /(W, Mo)- BiVO ₄ /FeOOH/NiOOH	0.5M K2SO4	94.23	46.32	September	2014	32
4	WO3-NRs/BiVO4+CoPi	pH 7	102	58	June	2015	33
5	TiO ₂ @BiVO ₄	0.1 M phosphate buffered saline (PBS)	16.17		September	2015	34
6	3 wt% RuO ₂ /GBVO _{0.10}	pH 7	48.7	25	October	2015	35
7	CDs/BiVO ₄ QDs	0.5M phosphate buffer	0.92	0.51	August	2016	36
8	WO ₃ /BiVO ₄ /TiO ₂	0.1 M Na ₂ SO ₄	25.6		October	2016	13
9	HDP(BiVO ₄ Fe ₂ O ₃)	1.0M KCl	100	54.5	December	2016	37
10	SrTiO3:La,Rh/C/BiVO4:Mo	0.1 M Na ₂ SO ₄	16.67	8.34	January	2017	38
11	BiVO ₄ -SnO ₂ -15/Pt	0.2 M sodium borate	1.16		April	2017	39
12	FeOOH/NiOOH + BiVO ₄ /(RGO/WO ₃)/W ₁₈ O ₄₉	0.5 M Na ₂ SO ₄	3.14	5.24	January	2018	16
13	FeCoO _x /BiVO ₄	1M potassium borate	86	42	June	2018	40
14	CoPi/NiMoO4/BiVO4	0.5 M Na ₂ SO ₄	94.65	46.7	June	2018	41
15	BiVO ₄ @Co-MIm	0.5 M Na ₂ SO ₄	53.67	26.34	April	2019	42
16	CoS/BiVO ₄	0.5 M Na ₂ SO ₄	51.9	25.7	April	2019	43
17	WO ₃ /g-C ₃ N ₄	0.04M Na2SO3 & 0.1 M Na2S	72.5		May	2019	44
18	b-BiVO ₄ /TiO ₂ -x	0.5M potassium phosphate	49.67	25.64	June	2019	45

		buffered with 1 m Na2SO3					
19	BiVO ₄ /CTP ₂	0.1 M phosphate buffer	67.6	33.8	October	2019	46
20	Fe ₂ O ₃ / BiVO ₄ 10	0.5 M Na ₂ SO ₄	46.34		November	2019	47
21	BVO/MoS _x (Nafion)–PV4	phosphate- buffered solution (PBS)	28.6	14.08	March	2020	48
22	BiVO ₄ /NiFeOOH/Co-Pi	0.5 M Na ₂ SO ₄	7	3.6	March	2020	49
23	WO ₃ -ZIF-67/BiVO ₄ -BP	0.5 M Na ₂ SO ₄	15.9	7.85	May	2020	50
24	0.8wt % g-C ₃ N ₄ /BiVO ₄	0.5 M Na ₂ SO ₄	21.4		June	2020	51
25	BiVO ₄ /Ov/FeOx	KPi	48.2	23.8	July	2020	52
26	ZnIn ₂ S ₄ /BiVO ₄	0.1 M Na ₂ SO ₄	62.44		August	2020	53
27	Cu ₂ O/Pt/BiVO ₄	10% methanol	1.7		December	2020	54
28	WO ₃ /S:Bi ₂ O ₃ /(Ga,W):BiVO ₄ /Co- Pi	0.1M K2HPO4	67.3	33.6	This we	ork	

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